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First Named Inventor: Richard A. Blanchard  
Group Art Unit: Unknown  
Examiner Name: Unknown  
Attorney Docket: BLAN-9

FORM PTO-1449  
COMMERCE

U.S. DEPARTMENT OF  
PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

37 CFR 1.98(b)

U.S. Patent Documents

Examiner Initials	Cite No.	U.S. Patent Number	Kind Code	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YY	Pages, Columns, Lines Where Relevant Passages or Figures Appear
CL		6,331,470		Sanfilippo et al.	12-18-01	
		6,277,703		Barlocchi et al.	8-21-01	
		6,204,098		Anceau	3-20-01	
		6,166,436		Maeda et al.	12-26-00	
		6,060,381		Nakagawara et al.	5-9-00	
		6,020,215		Yagi et al.	2-1-00	
		5,891,797		Farrar	4-6-99	
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Foreign Patent Documents

Examiner Initials	Cite No.	Office	Number	Kind Code	Name of Patentee or Applicant	Date of Publication MM-DD-YY	Location of Relevant Passages/Figures	T

Other Prior Art - Non Patent Literature Documents

Examiner Initials	Cite No	Name of Author (All Caps), Title of Article/Item, Date, Page(s), Volume-Issue Number(s), Publisher, City and/or Country Where Published	T
CL		KELLY, ET AL., Galvanic Cell Formation: A Review of Approaches to Silicon Etching for Sensor Fabrication, August 2001, IEEE Sensors Journal, Vol 1, No. 2, pg. 127-142.	
CL		LEE, The Fabrication of Thin, Freestanding, Single-Crystal, Semiconductor Membranes, August 1990, J. Electrochem. Soc., Vol. 137, No. 8, pg. 2556-2574.	

Examiner Signature	<i>calvyn</i>	Date Considered	5.20.04
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\*\*EXAMINER: Initial citation considered. Draw line through citation if no in conformance and not considered. Include copy of this form with next communication to application.